



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/881,408
Confirmation No. 8492
Filing Date June 13, 2001
Inventor Kie Y. Ahn, et al
Assignee Micron Technology, Inc.
Group Art Unit 2814
Examiner T. Le
Attorney's Docket No. MI22-1534
Customer No. 021567
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

RESPONSE TO NOVEMBER 19, 2003 OFFICE ACTION

To: Commissioner for Patents
PO Box 1450
Art Unit 2814
Alexandria, VA 22313-1450

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AMENDMENTS

No amendments.

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